



1763
PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date October 11, 2007

In re the Application of

Kazuo ICHIKAWA et al.

Group Art Unit: 1763

Application No.: 09/670,877

Examiner: R. ZERVIGON

Filed: September 27, 2000

Docket No.: 107469

For: CVD SUBSTRATE AND CLEANING METHOD

**LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION
OF TIME UNDER 37 C.F.R. §1.136(a) AND
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired August 16, 2007, an extension of time for a period of two months is hereby requested. Attached hereto is our Check No. 197941 in the amount of \$460 in payment for:

<u> </u>	Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
<u> X </u>	Extension fee for response within second month pursuant to §1.136(a) (\$460.00)
<u> </u>	Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1050.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

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Respectfully submitted,

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DEPOSIT ACCOUNT USE
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Please grant any extension
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